

Docket No.: 60188-756

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of

:

:

Toyokazu FUJII, et al.

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Serial No.: Divisional of Appl. No.

09/536,618

:

Group Art Unit:

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Filed: March 15, 2004

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Examiner:

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For: A SEMICONDUCTOR DEVICE HAVING IMPROVED PLANARIZATION  
PROPERTIES AND A METHOD FOR FORMING THE SAME (AS AMENDED)

**PRELIMINARY AMENDMENT**

Mail Stop Preliminary Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Prior to examination of the above-referenced application, please amend the application as follows: